IN THE UNITED STATES PATENT AND TRADEMARK OFFICE.

Applicants : Akihiko ENDO et al. Group Art Unit : 2891

Appl. No. : 10/570,669 Examiner: Asak K SARKAR

Filed: March 6, 2006 Confirmation No.: 1242

For : SOI WAFER AND ITS MANUFACTURING METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop <u>Amendment</u>
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

This paper is responsive to the Office Action mailed April 13, 2009. Applicants respectfully request reconsideration and withdrawal of each of the rejections in the outstanding Office Action, and request allowance of all the claims pending herein. Inasmuch as the three-month shortened statutory period is set in the Office Action to expire on July 13, 2009, this response is being filed in a timely manner and no extension of time or fee is deemed necessary. However, should any extension of time be deemed necessary, the same is hereby requested and the undersigned authorizes the Office to charge any extension of time fees or other fees required to maintain pendency of the application to Deposit Account No. 19-0089.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 3 of this paper.